ATTORNEY DOCKET NUMBER: 2336-254

Sir:

Fransmitted	herewith 1	for filin	g is the	Utility pater	it application of:

INVENTOR (S): Sun Woon KIM; In Eung KIM; Hun Joo HAHM; Soo Min LEE; Dong Joon KIM

FABRICATION METHOD OF NITRIDE SEMICONDUCTORS AND NITRIDE For:

SEMICONDUCTOR STRUCTURE FABRICATED THEREBY

Enclosed are:

20 pages of Specification, Claims and Abstract

5 sheet(s) of formal drawings

Declaration & Power of Attorney

Claim of Priority under 35 U.S.C. § 119

Certified copy of Korean Priority Document

An assignment conveying title in instant application to Samsung Electro-Mechanics Co., Ltd., with PTO Form 1595.

Preliminary Amendment

Information Disclosure Statement, PTO-1449 and Reference(s)

Change of Address

Return Receipt Postcard

The filing fee is calculated as shown below:

and the second s	NO. FILED		NO. EXTRA	RATE	AN	10UNT
Total Claims	13	MINUS 20		x \$18 =	\$	0.00
Independent Claims	3	MINUS 3		x \$86 =	\$	0.00
If multiple dependent claims are presented, add \$ 290.00						
				Basic Fee	\$	770.00
Applicant claims small entity status. See 37 CFR 1.27. The fees indicated above are reduced by ½.					\$	
			Total of ab	ove calculations	\$	770.00
					\$	40.00
			Γ	TOTAL FEE	\$	810.00

X	A credit card	authorization	form to cove	er the filin	a fees is	enclosed
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The Commissioner is hereby authorized to charge any additional fees associated with this communication, including patent application filing fees and processing fees under 37 C.F.R. § 1.16 and 1.17, or credit any overpayment to Deposit Account Number 07-1337.

is enclosed to cover the filing fees.

Respectfulk submitted.

LOWE AAUP MAN GILMAN & BERNER, LLP (22429)

Customer No. 22429 PATENT TRADEMARK OFFICE

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Date: March 23, 2004

BJH:AYH